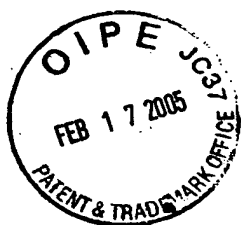


IFW



PATENT
Docket No. 20059/PIA31212

IN THE UNITED STATES PATENT
AND TRADEMARK OFFICE

Applicant(s):

Jae Suk Lee

U.S. Serial No.: 10/748,468

For: "Methods for Forming
Shallow Trench Isolation
Structures"

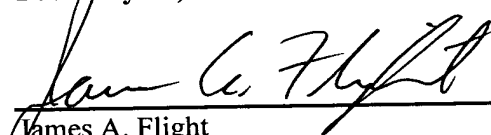
Filed: December 30, 2003

Group Art Unit: 2812

Examiner: Not Yet Assigned

) I hereby certify that this paper and the
) documents referred to as enclosed
) therewith are being deposited with the
) United States Postal Service as first
) class mail, postage prepaid, in an
) envelope addressed to Commissioner
) for Patents, P.O. Box 1450,
) Alexandria, Virginia 22313-1450 on
) this date:

) **February 14, 2005**

) 
) James A. Flight
) Attorney for Applicant(s)
) Registration No. 37,622

STATUS LETTER

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

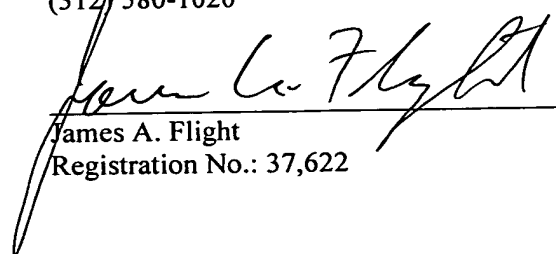
Kindly advise when an Office action can be expected in the above-referenced
matter.

Respectfully submitted,

HANLEY, FLIGHT & ZIMMERMAN, LLC
USPTO Customer Number 34431
20 North Wacker Drive
Suite 4220
Chicago, Illinois 60606
(312) 580-1020

February 14, 2005

By:


James A. Flight
Registration No.: 37,622